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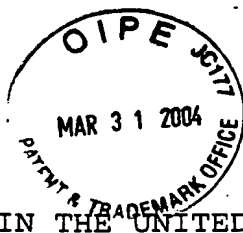
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SON-770

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of)
HIROYUKI MIWA) Att: Application Branch
Serial No. 08/532,057)
Filed: September 22, 1995)
For: BIPOLAR TRANSISTOR AND)
METHOD OF FABRICATING THE)
SAME)

CLAIM TO PRIORITY UNDER 35 U.S.C. 119

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

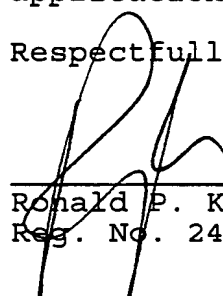
The benefit of the filing date of the following prior application filed in the following foreign country is hereby requested and the right of priority provided under 35 U.S.C. 119 is hereby claimed:

Japanese Patent Appl. No. P06-229612 filed September 26, 1994

In support of this claim, filed herewith is a certified copy of said original foreign application.

Respectfully submitted,

Dated: December 1, 1995



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日 本 国 特 許 庁

PATENT OFFICE
JAPANESE GOVERNMENT

別紙添付の書類に記載されている事項は下記の出願書類に記載されている事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed with this Office.

出 願 年 月 日

Date of Application:

1994年 9月26日

出 願 番 号

Application Number:

平成 6年特許願第229612号

出 願 人

Applicant(s):

ソニー株式会社

1995年 9月14日

特許庁長官
Commissioner,
Patent Office

清川 佑二

